1746

Patent Attorney's Docket No. <u>015290-500</u>

## N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re F	Patent Ap	oplication of	)		
Si Yi LI et al.			) Group Art Unit: 1746	Group Art Unit: 1746	
Application No.: 09/820,695			Examiner: Unassigned		
Filed:	March	30, 2001	)	RECEIVE	
For:	r: METHOD OF PLASMA ETCHING LOW-K DIELECTRIC MATERIALS		RECEIVED  JUL 2 0 2001  TC 1700		
			CLOSURE STATEMENT FTAL LETTER	- 1700	
		missioner for Patents O.C. 20231			
Sir:					
above-		ed is an Information Disclosure S d patent application.	Statement and accompanying form	PTO-1449 for the	
	[X]	No additional fee for submission	n of an IDS is required.		
	[]	The fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.			
	[]	A certification under 37 C.F.R. § 1.97(e) is also enclosed.			
	[ ] A certification under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.				
	[]	Charge \$to Depo	sit Account No. 02-4800 for the fe	ee due.	
	[]	A check in the amount of \$	is enclosed for the fee due		
	6, 1.17 a		to charge any appropriate fees und this paper, and to credit any overp abmitted in duplicate.		
			Respectfully submitted,		
		:	Burns, Doane, Swecker & Mat	HIS, L.L.P.	
Alexan	ox 1404 dria, Vi 336-6620	rginia 22313-1404	By: Peter K. Skiff Registration No. 31,917		
Date:		7-19-01			



SAU 1-24-00

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, , , , , , , , , , , , , , , , , , ,	TC 1-20 2001
INFORMATION DISCI	OSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

- U.S. Patent No. 5,013,398, Long et al., issued May 7, 1991
- U.S. Patent No. 5,013,400, Kurasaki et al., issued May 7, 1991
- U.S. Patent No. 5,021,121, Groechel et al., issued June 4, 1991
- U.S. Patent No. 5,022,958, Favreau et al., issued June 11, 1991
- U.S. Patent No. 5,269,879, Rhoades et al., issued December 14, 1993
- U.S. Patent No. 5,529,657, Ishii, issued June 25, 1996
- U.S. Patent No. 5,595,627, Inazawa et al., issued January 21, 1997
- U.S. Patent No. 5,611,888, Bosch et al., issued March 18, 1997
- U.S. Patent No. 5,736,457, Zhao, issued April 7, 1998
- U.S. Patent No. 5,780,338, Jeng et al., issued July 14, 1998
- U.S. Patent No. 5,820,261, Yam, issued October 13, 1998
- U.S. Patent No. 6,054,379, Yau et al., issued April 25, 2000
- U.S. Patent No. 6,090,304, Zhu et al., issued July 18, 2000

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- U.S. Patent No. 6,143,641, Kitch, issued November 7, 2000
- U.S. Patent No. 6,147,021, Hahn et al., issued November 14, 2000
- U.S. Patent No. 6,153,514, Wang et al., issued November 28, 2000
- U.S. Patent No. 6,153,935, Edelstein et al., issued November 28, 2000
- U.S. Patent No. 6,156,642, Wu et al., issued December 5, 2000
- U.S. Patent No. 6,168, 726, Li et al., issued January 2, 20001

PECEIVED TO 1700 The documents are being submitted within 3 months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: Peter K.

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Date: 7-18-01

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TRADEMAR **U.S. PATENT DOCUMENTS** U.S. Patent Document Examiner Kind Code Name of Patentee or Applicant Date of Publication Initials Number (if known) of Cited Document (MM-DD-YYYY) 5,013,398 05/07/91 Long et al. 5,013,400 05/07/91 Kurasaki et al. 5,021,121 Groechel et al. 06/04/91 5,022,958 Favreau et al. 06/11/91 5,269,879 Rhoades et al. 12/14/93 5,529,657 Ishii 06/25/96 5,595,627 lnazawa et al. 01/21/97 5,611,888 Bosch et al. 03/18/97 5,736,457 Zhao 04/07/98 5,780,338 07/14/98 Jeng et al. 5,820,261 Yam 10/13/98 6.054.379 Yau et al. 04/25/00 07/18/00 6,090,304 Zhu et al. 11/07/00 6,143,641 Kitch 6,147,021 11/14/00 Hahn et al. Wang et al. 11/28/00 6,153,514 Edelstein et al. 11/28/00 6,153,935 6,156,642 Wu et al. 12/05/00 6,168,726 01/02/01 Li et al. **FOREIGN PATENT DOCUMENTS** Foreign Patent Document Examiner Kind Code Date of Publication Translation Initials (if known) Country (MM-DD-YYYY) Number Yes no NON PATENT LITERATURE DOCUMENTS Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), Examiner Initials publisher, city and/or country where published. RECEIVED Examiner Date Considered Signature JUL 2 0 2001

TC 1700